

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Seong Deok Ahn et al.

Application No.: 10/672,013

Filed: September 26, 2003

For: **Method and Apparatus Using Large-Area  
Organic Vapor Deposition for Formation of  
Organic Thin Films or Organic Devices**

Examiner: Richard R. Bueker

Art Unit: 1763

Confirmation No.: 7684

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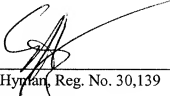
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Respectfully submitted,

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Dated: August 8, 2007

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STATEMENT BY APPLICANT**  
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**Complete if Known**

Application Number	10/672,013
Filing Date	September 26, 2003
First Named Inventor	Seong Deok AHN
Art Unit	1763
Examiner Name	Richard R. Bueker
Attorney Docket Number	2013P107

## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]Examiner  
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Based on PTO/SB/06A (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wtr) 08/11/2003.

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